

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/719,404	KLEIN ET AL.	
Examiner	Art Unit	
Jaha D. Walah	0454	

	SEARCHED					
Class	Subclass	Date	Examiner			

INTERFERENCE SEARCHED					
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709	217-229	11/24/2008	JW		
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SEARCH NO (INCLUDING SEARC)
·	DATE	EXMR
text search in EAST	11/24/2008	JW
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